

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masao SHINOZAKI et al.

Appln. No.:

Filed: Herewith

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants wish to make of record the documents cited
in prior Application No. 10/002,009 filed December 5, 2001,
whether cited by Applicants or by the Patent Office. The
documents are listed on the attached Form PTO-1449.

Respectfully submitted,

NHS:jab

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January 22, 2004

FORM PTO-1449				Atty. Docket No. XA-9590A		Appln. No.	
<u>LIST OF DOCUMENTS CITED BY APPLICANT</u>				Applicant Masao SHINOZAKI et al.			
				Filing Date Herewith		Group	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA	5,262,999	11/93	Etoh et al.	365	203	
	AB	5,329,182	7/94	Yu	326	126	
	AC	5,631,547	5/97	Fujioka et al.	323	273	
	AD	5,952,847	9/99	Plants et al.	326	58	
	AE	6,107,134	8/00	Lu et al.	438	239	
	AF	6,119,250	9/00	Nishimura et al.	365	201	
	AG	6,166,561	12/00	Fifield et al.	326	119	
	AH	6,392,439	5/02	Tanaka et al.	326	62	
	AI	6,414,536	7/02	Chao	327	540	
	AJ	6,417,037	7/02	Feng	438	216	
	AK						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						
	AR						
	AS						
OTHER (including author, title, date, pertinent pages, etc.)							
	AT						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							